

**Applicant:** 

Yoshiyuki Yanagisawa et al. Atty. Docket No.

075834.00085

**Serial No.:** 

09/876,290

**Group Art Unit:** 

2827

Filed:

June 7, 2001

**Examiner:** 

David E. Graybill

**Invention:** 

"ASSEMBLY JIG AND MANUFACTURING METHOD OF

MULTILAYER SEMICONDUCTOR DEVICE"

## **AMENDMENT B**

**Assistant Commissioner of Patents** Washington, D.C. 20231

SIR:

In response to the Office Action dated November 6, 2002, please amend the application as follows:

## PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a three-month extension of time to respond to the outstanding Office Action under 37 C.F.R. §1.136(a). The time to respond is thus extended to May 6, 2003. Applicant has also included a check in the amount of \$930.00 as payment of the required fee set forth in 37 C.F.R. §1.17(a).